

I hereby certify that this correspondence is being deposited with the United States Postal Service, with sufficient postage, as first class mail in an envelope addressed to:

Commissioner for Patents  
Washington, D.C. 20231

On 11-16-01

Date of Deposit

William A. Webb - Reg. No. 28,277

Name of applicant, assignee or  
Registered Representative

Signature WAW

11-16-01

Date of Signature

Our Case No. 10519/57

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Herner et al.

Serial No.: 09/928,975

Filing Date: August 13, 2001

For: LOW RESISTIVITY TITANIUM SILICIDE  
ON HEAVILY DOPED  
SEMICONDUCTOR

## INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
Washington, D.C. 20231

Commissioner:

Applicant has enclosed copies of documents A1-A4 as listed on the attached Form PTO 1449. These documents are discussed in the opening paragraphs of this Application, and Applicant requests that they be reviewed and made of record.

Respectfully submitted,

WAW  
William A. Webb  
Registration No. 28,277  
Attorney for Applicant

BRINKS HOFER GILSON & LIONE  
P.O. BOX 10395  
CHICAGO, ILLINOIS 60610  
(312) 321-4200